

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 3742**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of

Atsuo KONDO et al. Group Art Unit: 3742

Application No.: 10/581,748 Examiner: Q. VAN

Filed: June 6, 2006 Docket No.: 128342

For: PLASMA GENERATING ELECTRODE, ITS MANUFACTURING METHOD, AND  
PLASMA REACTOR

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 30, 2009 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**